

SLPC 2022 » Oral Presentation

Session 1: Blue LD Processing

Tue. Apr 19, 2022 9:00 AM - 10:30 AM Pacifico Yokohama Conference Center (416+417)

Session Chair: Yuji Sato (Osaka University), Yasuhiro Okamoto (Okayama University)

9:00 AM - 9:30 AM [WEB \(On-time video, Q&A by Dr. S. Takeda\)](#)

[SLPC1-01(Invited)] Blue diode lasers with increased power creating new opportunities in material processing

*Markus Ruetering¹, Luisa-Marie Heine¹, Soern Ocylok¹, Mathias Schlett¹ (1. Laserline GmbH)

9:30 AM - 10:00 AM

[SLPC1-02(Invited)] Laser Welding for Copper with Blue-IR Hybrid Laser "BRACE™"

*Tomomichi Yasuoka¹, Nobuyasu Matsumoto¹, Kazuyuki Umeno¹, Masamitsu Kaneko¹, Tatsuya Yoshizaki¹, Takashi Kayahara¹, Takashi Shigematsu¹ (1. FURUKAWA ELECTRIC CO., LTD.)

10:00 AM - 10:15 AM

[SLPC1-03] KW-class blue direct diode laser for copper welding

*Masaya Suwa¹, Naoki Wakabayashi¹, Naoya Ishigaki¹, Minoru Yamada¹, Tomoyuki Hiroki¹, Shingo Uno¹, Koji Tojo¹, Masahiro Tsukamoto² (1. Shimadzu Corporation, 2. Joining and Welding Research Institute, Osaka University)

10:15 AM - 10:30 AM

[SLPC1-04] Copper alloy layer formation of high intensity blue diode lasers for inactivation of virus

*Yuji Sato¹, Keisuke Takenaka¹, Tsuneyoshi Kamata², Masahiro Tsukamoto¹
(1. JWRI, Osaka University, 2. Mitsui Mining and Smelting Co. Ltd)

SLPC2022

The 4th Smart Laser Processing Conference

Organized by Japan Laser Processing Society (JLPS)

Co-organized by Joining and Welding Research
Institute, Osaka University



SLPC2022-The 4th Smart Laser Processing Conference

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Session 2: Industrial Applications

Tue. Apr 19, 2022 10:45 AM - 12:00 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Yasuhiro Okamoto (Okayama University), Yuji Sato (Osaka University)

10:45 AM - 11:15 AM

[SLPC2-01(Invited)] Laser material processing in E-mobility

*Tsuyoshi Nakamura¹, Matthias Beranek² (1. TRUMPF Corporation, 2. TRUMPF Laser- und Systemtechnik GmbH)

11:15 AM - 11:30 AM

[SLPC2-02] Effects of Laser Peening with PDMS as Plasma Confinement Layer

*Yang Zhang¹, Takumi Besshi¹, Miho Tsuyama¹, Manabu Heya², Hitoshi Nakano¹ (1. Kindai University, 2. Osaka-sangyo University)

11:30 AM - 12:00 PM [WEB \(Remote-live\)](#)

[SLPC2-03(Invited)] Laser Weeding – A New Technology for Sustainable Weed Management

*Merve Wollweber¹, Tammo Ripken¹ (1. Laser Zentrum Hannover e.V.)

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Session 3: AI/CPS Processing and Ultrashort Pulsed Laser Processing

Tue. Apr 19, 2022 1:15 PM - 3:00 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Aiko Narazaki (National Institute of Advanced Industrial Science and Technology), Rie Yamagishi (Fukuoka Institute of Technology)

1:15 PM - 1:45 PM

[SLPC3-01(Invited)] Femtosecond laser processing with adaptive optics based on machine learning

*Satoshi Hasegawa¹, Yoshio Hayasaki¹ (1. Utsunomiya University)

1:45 PM - 2:00 PM

[SLPC3-02] Laser welding depth classification by deep learning using laser welding surface emission observation images

*Toshifumi Kikuchi¹, Ryuma Takabatake¹, Tsubasa Fujimoto¹, Hiroshi Ikenoue¹, Daisuke Nakamura¹ (1. Kyushu University)

2:00 PM - 2:15 PM

[SLPC3-03] Estimating transistor characteristics from low temperature polycrystalline silicon surface images using deep learning

*Keita Katayama¹, Takayuki Kurashige¹, Takahiro Nagano¹, Yoshiaki Kakimoto^{1,2}, Akira Mizutani¹, Daisuke Nakamura¹, Tetsuya Goto³, Hiroshi Ikenoue^{1,2}

(1. Graduate School of Information Science and Electrical Engineering, Kyushu University, 2. Department of Gigaphoton Next GLP, Kyushu University, 3. New Industry Creation Hatchery Center, Tohoku University)

2:15 PM - 2:45 PM

[SLPC3-04(Invited)] Crystallinity evaluation in periodic structures induced by femtosecond laser pulses

*Reina Miyagawa¹, Daisuke Kamibayashi², Hirotaka Nakamura^{2,3}, Masaki Hashida^{4,5}, Heishun Zen⁶, Takeshi Matsuoka⁷, Hiroyuki Ogura², Daisuke Sagae², Yusuke Seto⁸, Takahisa Shobu⁹, Ai Tominaga⁹, Osamu Eryu¹, Norimasa Ozaki^{2,3}

(1. Nagoya Institute of Technology, 2. Graduate School of Engineering, Osaka University, 3. Institute of Laser Engineering, Osaka University, 4. Institute for Chemical Research, Kyoto University, 5. Research Institute of Science and Technology, Tokai University, 6. Institute of Advanced Energy, Kyoto University, 7. Institute for Open and Transdisciplinary Research Initiatives, Osaka University, 8. Graduate School of Science, Kobe University, 9. Quantum Beam Science Center, Japan Atomic Energy Agency)

2:45 PM - 3:00 PM

[SLPC3-05] Control of cell behavior on the PMMA surface by LIPSS with a femtosecond laser pulse

*Keisuke Takenaka¹, Yuji Sato², Masahiro Tsukamoto²

(1. Graduate school of engineering, Osaka university, 2. Joining and Welding Research Institute, Osaka University)

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Session 4: Plenary Talks of SLPC2022

Tue. Apr 19, 2022 3:30 PM - 5:30 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Masahiro Tsukamoto (Osaka University), Yuji Sato (Osaka University)

3:30 PM - 4:10 PM

[SLPC4-01(Invited)] The Role of TRAFAM and AM Technology Developments

*Hideki Kyogoku¹ (1. Kindai University, Japan)

4:10 PM - 4:50 PM

[SLPC4-02(Invited)] Cyber-Physical System of laser processing

*Yohei Kobayashi¹ (1. The University of Tokyo)

4:50 PM - 5:30 PM [WEB \(Remote-live\)](#)

[SLPC4-03(Invited)] Fully Digitalized Production Chains
for Medical Implants in Ophthalmology

*Reinhart Poprawe^{1,2}, Axel von Wallfeld¹, Uwe M. Clasen¹

(1. AIXlens GmbH, Germany, 2. Fraunhofer Germany, Chair for Lasertechnology RWTH Aachen University, Germany)

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Session 5: Micro Nano Processing

Wed. Apr 20, 2022 1:30 PM - 3:00 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Yoshio Hayasaki (Utsunomiya University), Miho Tsuyama (Kindai University)

1:30 PM - 1:45 PM [WEB \(Remote-live\)](#)

[SLPC5-01] Direct writing of SiC micropatterns in ambient atmosphere using near-infrared femtosecond laser sintering

*Tatsuru Kawabori¹, Masashi Watanabe², Yoshiyuki Imai², Xing Yan², Mizue Mizoshiri¹

(1. Nagaoka University of Technology, 2. Japan Atomic Energy Agency)

1:45 PM - 2:00 PM [WEB \(Remote-live\)](#)

[SLPC5-02] Laser Processing for Shape Memory Actuators

*Marvin Schuleit¹, Benedict Theren², Burkhard Maaß³, Bernd Kuhlenkötter², Cemal Esen¹, Andreas Ostendorf¹

(1. Applied Laser Technologies, Ruhr University Bochum, 2. Production Systems, Ruhr University Bochum, 3. Ingpus GmbH)

2:00 PM - 2:30 PM [WEB \(On-time video\)](#)

[SLPC5-03(Invited)] Damage-Less Singulation of Ultra-Thin Wafers using Stealth Dicing Technology

*Natsuki Suzuki¹, Koji Kuno¹, Takayuki Ohba² (1. Hamamatsu Photonics K.K., 2. Tokyo Institute of Technology)

2:30 PM - 2:45 PM

[SLPC5-04] Drilling characteristics of glass with large thermal expansion coefficient by short-pulse CO₂ laser

*Md. Ekhlasur Rahaman¹, Kazuyuki Uno¹

(1. Integrated Graduate School of Medicine, Engineering and Agricultural Science, University of Yamanashi)

2:45 PM - 3:00 PM

[SLPC5-05] Time-resolved spectroscopy of glass ablation during micro-via processing using 248 nm excimer laser for semiconductor interposer packaging

*Yasufumi Kawasuji¹, Yasuhiro Adachi¹, Kazuhiko Moro¹, Kouji Kakizaki¹, Masakazu Washio² (1. Gigaphoton Inc., 2. Waseda University)

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Session 6: Ultrashort Pulsed Laser Processing

Wed. Apr 20, 2022 3:15 PM - 5:00 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Masaki Hashida (Tokai University), Hitoshi Nakano (Kindai University)

3:15 PM - 3:30 PM

[SLPC6-01] Three-temperature model for laser processing of silicon and its dependence on laser parameters

*Prachi Venkat¹, Tomohito Otobe¹ (1. Kansai Photon Science Institute, National Institutes for Quantum Science and Technology, Kyoto)

3:30 PM - 4:00 PM

[SLPC6-02(Invited)] Ultrafast processing of glass by selective absorption of continuous-wave laser into transiently excited electrons

*Yusuke Ito¹, Reina Yoshizaki¹, Naohiko Sugita¹ (1. The University of Tokyo, Japan)

4:00 PM - 4:15 PM

[SLPC6-03] Holographic femtosecond laser processing of a glass with three-dimensionally arranged focused beams

*Yoshio Hayasaki¹, Honghao Zhang¹, Satoshi Hasegawa¹ (1. Utsunomiya University)

4:15 PM - 4:30 PM

[SLPC6-04] Multifocusing of ultrashort laser pulses using dispersion control techniques based on hybrid optics

*Jun Amako¹, Hidetoshi Nakano¹ (1. Faculty of Science and Engineering, Toyo University)

4:30 PM - 4:45 PM

[SLPC6-05] Precise generation of three-dimensional focused beams for holographic femtosecond laser processing

*Fumiya Ishita¹, Honghao Zhang¹, Satoshi Hasegawa¹, Yoshio Hayasaki¹
(1. Center for Optical Research and Education, Utsunomiya University)

4:45 PM - 5:00 PM

[SLPC6-06] Holographic laser grooving using the scanning parallel beam method

*Yuta Nakamura¹, Tomonari Tanaka¹, Satoshi Hasegawa¹, Yoshio Hayasaki¹ (1. Utsunomiya University)

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Session 7: Short Wavelength Application

Thu. Apr 21, 2022 9:00 AM - 10:00 AM Pacifico Yokohama Conference Center (416+417)

Session Chair: Katsuhiko Mikami (Kindai University), Masahito Katto (University of Miyazaki)

9:00 AM - 9:30 AM

[SLPC7-01(Invited)] Study on Nanoscale Response of Silicon under Femtosecond Extreme Ultraviolet Irradiation

*Thanh-Hung Dinh¹, Toshiyuki Kitamura¹, Masahiko Ishino¹, Noboru Hasegawa¹, Yoshiteru Yonetani¹, Masaharu Nishikino¹
(1. National Institutes for Quantum Science and Technology)

9:30 AM - 9:45 AM

[SLPC7-02] Progress of DUV · EUV Light Source and its Extension to Leading Edge Semiconductor Manufacturing

*Hakaru Mizoguchi¹, Koji Kakizaki¹, Hiroaki Nakarai¹, Hiroshi Ikenoue², Seiji Shiratani², Yasutsugu Usami¹ (1. Gigaphoton, 2. Kyushu University)

9:45 AM - 10:00 AM

[SLPC7-03] Excimer laser doping of low-resistance Ni ohmic contacts to n-type 4H-SiC

*Yoshiaki Kakimoto^{1,2}, Keita Katayama¹, Takuma Yasunami¹, Tetsuya Goto³, Daisuke Nakamura¹, Hiroshi Ikenoue¹
(1. Kyushu University, 2. Gigaphoton Inc, 3. Tohoku University)

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Session 8: Welding

Thu. Apr 21, 2022 1:30 PM - 3:00 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Yorihiro Yamashita (National Institute of Technology, Ishikawa College), Takahiro Kunimine (Kanazawa University)

1:30 PM - 1:45 PM

[SLPC8-01] Investigations of plasma effects from large-diameter Kilowatt cw laser beams on Aluminum samples

*Dominic Heunoske¹, Jens Osterholz¹ (1. Fraunhofer EMI)

Canceled as of April 8

1:45 PM - 2:00 PM

[SLPC8-02] Laser Welding of Ultra-high Strength Steel to Aluminum with Cold-sprayed Steel Coating Interlayer

*Kyohei Maeda^{1,2}, Yuji Sato¹, Reiichi Suzuki², Tetsuo Suga¹, Masahiro Tsukamoto¹ (1. Osaka University, 2. Kobe Steel)

2:00 PM - 2:15 PM [WEB](#)

[SLPC8-03] Increased gap bridgability and stability with multi-spot laser beam

*Joerg Volpp¹, Alexander Laskin² (1. Lulea University of Technology, 2. AdlOptica GmbH)

2:15 PM - 2:30 PM

[SLPC8-04] Study on Irradiation Method of Near-infrared Laser Beam in Welding of Copper

*Akihiro Ochi¹, Yasuhiro Okamoto¹, Akira Okada¹, Takeshi Yamamura², Norio Nishi² (1. Okayama University, 2. Kataoka Corporation)

2:30 PM - 3:00 PM [WEB](#)

[SLPC8-05(Invited)] Blue Diode Laser for Welding of Thin Foil Metals

*Tim Pasang¹, Pai-Chen Lin², Wojciech Misiolek³, Jia-Yuan Wei², Shinichiro Masuno⁴, Masahiro Tsukamoto⁴, Eiji Hori⁴, Yuji Sato⁴, Yuan Tao⁵, Danang Yudhistiro⁶, Salahuddin Yunus⁶

(1. Department of Manufacturing, Mechanical Engineering and Technology, Oregon Institute of Technology, USA, 2. AIM-HI, National Chung Cheng University, Taiwan, 3. Loewy Institute, Department of Materials Science and Engineering, Lehigh University, USA, 4. Joining and Welding Research Institute (JWRI), Osaka University, Japan, 5. Department of Mechanical Engineering, Auckland University of Technology, New Zealand, 6. Department of Mechanical Engineering, Universitas Jember, Indonesia)

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Session 9: Welding / Additive Manufacturing & Selective Laser Melting

Thu. Apr 21, 2022 3:15 PM - 4:30 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Takahiro Kunimine (Kanazawa University), Yorihiro Yamashita (National Institute of Technology, Ishikawa College)

3:15 PM - 3:30 PM

[SLPC9-01] Laser superposition processing technology using two beams with different energy densities

*Kazuo Hasegawa^{1,2}, Kan'ichi Tsunoda¹, Satoru Kato¹

(1. Toyota central R&D labs., inc., 2. The Graduate School for the Creation of New Photonics Industries)

3:30 PM - 4:00 PM

[SLPC9-02(Invited)] Investigating new concepts for improving the additive manufacturing process on industrial level

*Markus Kogel-Hollacher¹, Frédéric Adam¹, Christian Staudenmaier¹, Matthias Strebel¹, Steffen Boley³, Stan Watanabe²

(1. Precitec GmbH & Co. KG, Germany, 2. Precitec Japan Ltd, 3. Institut für Strahlwerkzeuge (IFSW))

4:00 PM - 4:15 PM

[SLPC9-03] Microstructures and Mechanical Properties of CrMnFeCoNi Multicomponent Alloys Additively Manufactured by Multi-Beam Laser DED

Kaito Nakagawa¹, Tatsuya Sakurai¹, Yorihiro Yamashita², *Takahiro Kunimine¹

(1. Kanazawa University, 2. National Institute of Technology, Ishikawa College)

4:15 PM - 4:30 PM

[SLPC9-04] Experimental investigation and simulation of superelastic behavior of NiTi gyroid structures manufactured via SLM

*Stanislav V. Chernyshikhin¹, Farzad Karimi², Igor V. Shishkovsky¹

(1. Skolkovo Institute of Science and Technology, 2. Sharif University of Technology)

SLPC 2022 » Poster Presentation

Poster Session

Thu. Apr 21, 2022 10:30 AM - 12:00 PM Pacifico Yokohama Exhibition Hall A (Hall A IP)

[SLPCp-01] Consideration of Two-Dimensional CPC for Pumping Cavity of Solar-Pumped Laser

*Hirozumi Munakata¹, Tomomasa Ohkubo¹, Ei-ichi Matsunaga¹, Thanh-hung Dinh², Yuji Sato³

(1. Graduate School of Engineering, Tokyo University of Technology, 2. National Institutes for Quantum Science and Technology, 3. Joining and Welding Research Institute, Osaka University)

[SLPCp-02] Early stage of Si surface processing by femto-second Ti:sapphire laser pulses

*Masahito Katto¹, Masanori Kaku¹, Masahiro Tsukamoto², Yuji Sato², Atsushi Yokotani¹ (1. University of Miyazaki, 2. Osaka University)

[SLPCp-03] Spatial profile measurement of mid-infrared free electron laser for LIPSS research

*Shin-ichiro Masuno¹, Masaki Hashida^{1,2}, Heishun Zen³, Takeshi Nagashima⁴, Norimasa Ozaki⁵, Hitoshi Sakagami⁶, Shigeru Yamaguchi⁷, Satoru Iwamori^{2,8}

(1. Advanced Research Center for Beam Science, Institute for Chemical Research, Kyoto University, 2. Research institute of Science and Technology, Tokai University, 3. Institute of Advanced Energy, Kyoto University, 4. Faculty of Science and Engineering, Setsunan University, 5. Graduate School of Engineering, Osaka University, 6. National Institute for Fusion Science, 7. Department Physics, Tokai University, 8. Department of Mechanical Engineering, Tokai University)

[SLPCp-04] In situ measurement of LIPSS formation with high-spatiotemporal resolution

*Masaki Hashida¹, Shin-ichiro Masuno², Yohei Tanaka^{3,2}, Heishun Zen⁴, Takeshi Nagashima⁵, Norimasa Ozaki⁶, Hitoshi Sakagami⁷, Shunsuke Inoue^{2,3}, Shigeru Yamaguchi⁸, Satoru Iwamori⁹

(1. Research institute of Science and Technology, Tokai University, 2. Graduate School of Science, Kyoto University, 3. Institute for Chemical Research, Kyoto University, 4. Institute of Advanced Energy, Kyoto University, 5. Faculty of Science and Engineering, Setsunan University, 6. Graduate School of Engineering, Osaka University, 7. National Institute for Fusion Science, 8. Department Physics, Tokai University, 9. Department of Mechanical Engineering, Tokai University)

[SLPCp-05] Effects of Laser Irradiation Conditions on WC Particle Size and Hardness of WC-Co Cemented Carbide Processed by Directed Energy Deposition

*Yorihiro Yamashita¹, Takahiro Kunimine², Yoshinori Funada³, Yuji Sato⁴, Masahiro Tsukamoto⁴

(1. National Institute of Technology, Ishikawa College, 2. Institute of Science and Engineering, Kanazawa University, 3. Industrial Research Institute of Ishikawa, 4. Joining and Welding Research Institute, Osaka University)

[SLPCp-06] Micro-coating of pure copper by multi-beam LMD method with high intensity blue diode lasers

*Yuma Takazawa¹, Kazuhiro Ono¹, Yuki Morimoto², Keisuke Takenaka¹, Yuji Sato³, Manabu Heya², Masahiro Tsukamoto³

(1. Graduate School of Engineering, Osaka University, 2. Faculty of Engineering, Osaka Sangyo University, 3. Joining and Welding Research Institute, Osaka University)

[SLPCp-07] Thin-film formation of polymer sheets by the CO₂ laser with the copper base

*Nobukazu Kameyama¹, Hiroki Yoshida¹ (1. Gifu University)

[SLPCp-08] Homogenization Towards a Grain Size of SLMed Plate with Modulated Pulsed Laser

*Yuta Mizuguchi¹, Masahiro Ihama¹, Yuji Sato², Norio Yoshida², Sasitorn Srisawadi³, Dhriti Tanprayoon³, Masahiro Tsukamoto²

(1. Osaka University, 2. Joining and Welding Research Institute, Osaka University, 3. National Metal and Materials Technology Center)

[SLPCp-09] Effect of ambient pressure on denudation zone for development of SLM in vacuum

*Masahiro Ihama¹, Yuta Mizuguchi¹, Keisuke Takenaka², Norio Yoshida², Yuji Sato², Tsukamoto Masahiro²

(1. Graduate School of Engineering, Osaka University, 2. Joining and Welding Research Institute, Osaka University)

[SLPCp-10] Copper rod formation using multi-beam laser metal deposition system with blue diode lasers

*Ritsuko Higashino¹, Yuji Sato¹, Keisuke Takenaka¹, Kazuhiro Ono², Yoshinori Funada³, Yorihiro Yamashita⁴, Nobuyuki Abe¹, Masahiro Tsukamoto¹

(1. Joining and Welding Research Institute, Osaka University, 2. Graduate School of Engineering, Osaka University, 3. Industrial Research Institute of Ishikawa, 4. National Institute of Technology Ishikawa College)

[SLPCp-11] Real-time observation of molten pool shape in keyhole-type welding for stainless steel using a 16kW disk laser

*Tomoki Arita¹, Yoshiaki Kurita², Masami Mizutani³, Yuji Sato³, Hitoshi Nakano¹, Masahiro Tsukamoto³

(1. Graduate School of Science and Engineering, Kindai University, 2. Graduate School of Engineering, Osaka University, 3. Joining and Welding Research Institute, Osaka University)

[SLPCp-12] Investigation of keyhole dynamics in laser welding of pure copper using in situ X-ray observation system

*Shumpei Fujio¹, Tomoki Arita², Yoshiaki Kurita¹, Keisuke Takenaka³, Masami Mizutani³, Yuji Sato³, Hitoshi Nakano², Masahiro Tsukamoto³

(1. Graduate School of Engineering, Osaka University, 2. Graduate School of Science and Engineering, Kindai University, 3. Joining and Welding Research Institute, Osaka University)

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Awards & Closing Remark

Thu. Apr 21, 2022 4:30 PM - 5:00 PM Pacifico Yokohama Conference Center (416+417)

Session Chair: Masahiro Tsukamoto (Osaka University), Yuji Sato (Osaka University)

4:30 PM - 5:00 PM

[SLPC-Closing] Closing Remarks